

Notice of References Cited	Application/Control No. 09/930,838	Applicant(s)/Patent Under Reexamination AMM ET AL.	
	Examiner John Juba	Art Unit 2872	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,445,502	09-2002	Islam et al.	359/290
	B	US-2002/0105725 A1	12-2000	Sweatt et al.	359/566
	C	US-2002/0015230 A1	05-2001	Pilossof et al.	359/558
	D	US-2002/0079432 A1	08-2001	Lee et al.	250/216
	E	US-6,396,789	05-2002	Guerra et al.	369/112.01
	F	US-2002/0021485 A1	07-2001	Pilossof, Nissim	359/295
	G	US-6,268,952	07-2001	Godil et al.	359/247
	H	US-6,252,697	06-2001	Hawkins et al.	359/290
	I	US-6,071,652	06-2000	Feldman, et al.	430/5
	J	US-5,999,319	12-1999	Castracane, James	359/572
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	D.M. Burns, et al., "Development of microelectromechanical variable blaze gratings", Sensors and Actuators A 64 (1998) 7-15.
	V	NASA's Jet Propulsion Laboratory, "Micromachined Opto/Electro/Mechanical Systems", NASA Tech Briefs, March 1997, pp. 50-51.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.